

Docket Number: 081468-0308088

Client Reference: P-0345.011-US

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Reissue Application of LEONID SHMAENOK Group Art Unit: 2622

Application No.: 10/803,201

Examiner:

Filed: March 18, 2004

Confirmation No.: 4831

For: FILTER FOR EXTREME ULTRAVIOLET LITHOGRAPHY

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

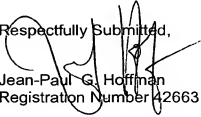
Sir:

Attached is a Form PTO-1449. Some of the references were cited in and submitted during the prosecution of the parent application, U.S. Application No. 09/641,455, filed on August 18, 2000, now U.S. Patent No. 6,359,969, issued March 19, 2002, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 C.F.R. §1.98(d). It is respectfully requested that all of the references be made of record in the present application.

Applicant notes that the face of U.S. Patent No. 6,359,969 (for which this re-issue application has been filed) indicates the foreign patent document "EP 07180042". This reference should actually be indicated as "JP 7-180042". A copy of this Japanese patent application publication is enclosed herewith. The confusion may be attributed to the fact that Applicant originally submitted an English language abstract of JP 7-180042 prepared by the European Patent Office. Accordingly, Applicant requests that any re-issue patent from this application correctly identify that "JP 7-180042" was cited, not "EP 07180042".

This Information Disclosure Statement is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

Respectfully Submitted,


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FORMPTO-1449 (modified)
To: U.S. Department of Commerce
(PW FORM PAT-1449)
Patent and Trademark Office



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Client Ref.

308088

P-0345.011-US

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Applicant: SHMAENOK

Appln. No. 10/803,201

Filing Date: March 18, 2004

Examiner: ~~Unknown~~

Group Art Unit: 2882

Date: August 25, 2004

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of

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U.S. PATENT DOCUMENTS

I. Kiknadze

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
/IK/	AR 1,865,441	07/1932	Mutscheller			
	BR 4,242,588	12/1980	Silk et al.			
	CR 4,672,648	06/1987	Mattson et al.			
	DR 4,741,012	04/1988	Duinker et al.			
	ER 4,825,454	04/1989	Annis et al.			
	FR 4,837,794	06/1989	Riordan et al.			
	GR 5,099,134	03/1992	Hase et al.			
	HR 5,570,408	10/1996	Gibson			
/IK/	IR 5,768,339	06/1998	O'Hara			
JR						
KR						

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Ready Available	
					Enclosed	No	Enclosed	No
/IK/	LR 0682125 A1	11/1995	Europe	Parker				
/IK/	MR 7-180042	07/1995	Japan	Sato				
/IK/	NR WO 96/10324	04/1996	PCT	Shmaenok				
QR								
PR								
QR								
RR								
SR								
TR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

/IK/	UR	"Collimator for X-Ray Lithography," IBM Technical Disclosure Bulletin, September 1990, 33(4):278-9.						
/IK/	VR	Vartanian et al., "Polycapillary Collimator For Point Source Proximity X-ray Lithography," Journal of Vacuum Science & Technology, 1993, Part B, 11(6):3003-7.						
WR								
XR								
YR								
ZR								
AAR								
BBR								
CCB								
DDR								

Examiner /Irakli Kiknadze/

Date Considered:

04/13/2008

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.